



520.42972X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: YODA et al

Serial No.: 10/629,623

Filed: July 30, 2003

For: Multi-Electron Beam Exposure Method And Apparatus

Group: 2881

Examiner: K. Nguyen

AMENDMENT UNDER 37 CFR 1.312(a)

Mail Stop: Issue Fee
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

July 25, 2005

Sir:

The following amendments are respectfully requested in connection
with the above-identified application:

Amendments to the Claims;

Remarks following the Amendments.